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# Polymerization of Fluoroalkyl Polyhedral Oligomeric Silsesquioxane (F-POSS) Macromers

Sean M. Ramirez,<sup>1</sup> Yvonne Diaz,<sup>2</sup> Timothy S. Haddad,<sup>1</sup> and Joseph M. Mabry<sup>2</sup>

<sup>1</sup>ERC Inc., Air Force Research Laboratory, Rocket Propulsion Division, Edwards AFB, CA 93524-7680 U.S.A.

Phone: (661) 275-5769, sean.ramirez.ctr@edwards.af.mil

<sup>2</sup>Air Force Research Laboratory, Rocket Propulsion Division, Edwards AFB, CA 93524-7680 U.S.A.

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#### Introduction to F-POSS



(1,1,2,2-tetrahydroperfluorodecyl) $_8$ Si $_8$ O $_{12}$  Polyhedral Oligomeric Silsesquioxane (POSS), or fluorodecyl POSS

- hybrid organic-inorganic structure
- well-defined polyhedral architecture
- long-chain fluoroalkyl substituents on periphery of cage

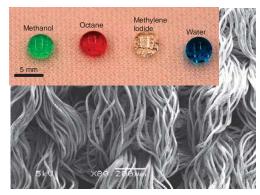
Due to its unique structure, fluorodecyl POSS has one of the lowest surface energies of any crystalline solid currently known

fluorodecyl POSS
 polytetrafluoroethylene
 CF<sub>3</sub> monolayer
 9.3 mN/m
 18-20 mN/m
 6.7 mN/m

Low surface energy and other unique properties of fluorodecyl POSS has enabled the development of various types of tunable non-wetting polymeric surfaces



Superhydrophobic/oleophilic dip-coated fabric Tuteja *et al*, Science, **2007**, 318, 1618



Superamphiphobic dip-coated fabric Choi *et al*, Adv Mater, **2009**, 21, 2190



Superamphiphobic electrospun surfaces Tuteja *et al*, PNAS, **2008**, 105, 18200



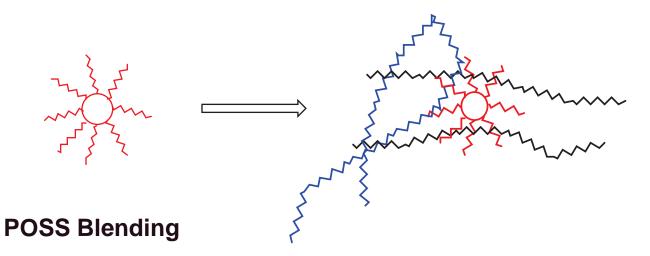
# **POSS Incorporation in Polymers**



**Cross-linker** 

**Pendant Polymer** 

**Bead Copolymer** 





# **Functional F-POSS (Open-Caged)**



- Close-caged structures are accessible and have proven versatile in polymer composites
  - Limitations
    - Solubility, mechanical robustness (surface abrasion), no sites for functionality
- Open-caged structures would allow for functionalization of F-POSS
  - Open door for use a building block material for low surface energy materials
- Applications
  - Mechanical robust superhydrophobic/oleophobic/omniphobic surfaces
    - Via covalently attached F-POSS to substrate (surface, nanoparticle, polymer matrix)
  - Effects on polymer composite properties
    - Wetting, phase behavior, solubility, etc....

- Open cages lead to functional POSS structures
- Reactions are simple
- High yields typically reported



# Methods to Produce Incompletely Condensed Silsesquioxanes



- Bottom-up approach
  - Acid or base mediated from RSiCl<sub>3</sub> or RSi(OR)<sub>3</sub>
  - Condensation reaction
  - Balance of stoichiometry, temperature, reaction time, patience, and luck
  - Stopping POSS synthesis early, before cages closes
  - More common approach

- Top-down Approach
  - Strong acid or base mediated
  - Starting from a POSS cage
  - Conversion of Si-O-Si bonds to Si-O (-) C(+) or Si-OH bonds
  - Opening up POSS cage

Which method can be applied to long-chain F-POSS?



# **Incompletely Condensed Silsesquioxane**

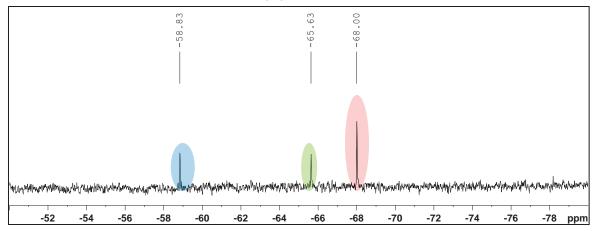


$$\begin{array}{c} R_f \\ R_f \\ Si \\ O \\ Si$$

<sup>a</sup>Conditions: All reactions were performed in C<sub>6</sub>F<sub>6</sub> at 25 °C. <sup>b</sup>CF<sub>3</sub>SO<sub>3</sub>H, 75 mins. <sup>c</sup>NBut<sub>4</sub>HSO<sub>4</sub>, 30 mins, <sup>d</sup>(CF<sub>3</sub>)<sub>2</sub>CH<sub>2</sub>OH/H<sub>2</sub>O (10:1), 12 hrs.

 Incompletely condensed silsesquioxane synthesis yields a disilanol capable of functionalization with dichlorosilanes.

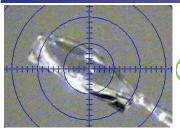
#### $^{29}$ Si NMR in $C_6F_6$ of disilanol F-POSS

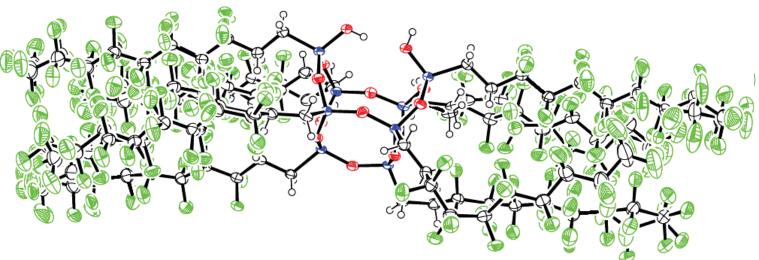




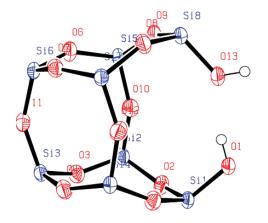
# X-Ray Crystal Structure of Disilanol

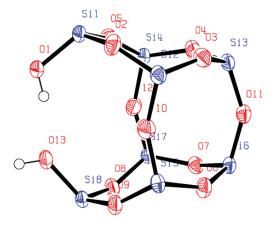






- Crystal structure is dimeric via intra- and intermolecular hydrogen bonding between silanols.
- M<sub>r</sub>=,monoclinic, space group P2(1)/c , a=11.84(10) Å, b=57.11(6) Å, c=19.06(2) Å,  $\alpha$ = 90.00°,  $\beta$ =92.21(10)°,  $\gamma$ =90.00°, V= 12878(2) Å<sup>3</sup>







# **Edge Capping Reactions**



 $R = CH_2CH_2(CF_2)_7CF_3$   $R_1 =$ alkyl or aromatic  $R_2 =$ alkyl or aromatic

- Edge capping reactions typically have 40-90% yield
- Main side product is starting material (recycled)
- Disilanol can revert back to closed cage during reaction



## <sup>29</sup>Si NMR of F-POSS Structures



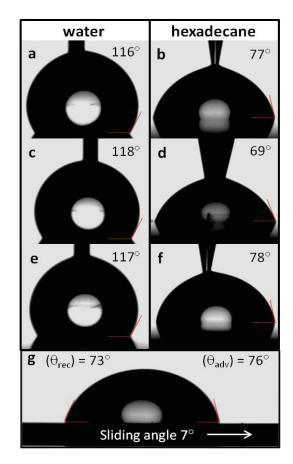


# **Contact Angle Measurements**



- Non-wetting surfaces can be developed by a combination of three parameters
  - Chemical functionality (high fluorine content)
  - Roughness (micro- and nanoscale)
  - Surface Geometry (re-entrant curvature)
- What type of influence will functional groups have on F-POSS surface properties?
- Solvent impact?

$$H_3C(CH_2)_7$$
  $Si$   $(CH_2)_7CH_3$   $R_f$   $Si$   $Si$   $Si$   $R_f$   $Si$   $Si$   $Si$   $R_f$   $Si$   $Si$   $Si$   $R_f$   $R_f$ 

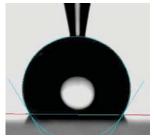


Static contact angles of Si wafer surfaces coated with compounds **disilanol** (a) and (b), **dioctyl** (c) and (d), and **diphenyl** (e) and (f). Image of hexadecane droplet  $(10\mu\text{L})$  rolling off surface coated with compound **diphenyl** (g).



# **Dynamic Contact Angle Measurements**





Functional Group on F-POSS	wai	ter	hexadecane		
	$(\theta_{adv})$	$(\theta_{\rm rec})$	$(\theta_{adv})$	$(\theta_{\rm rec})$	
F-POSS*	$124 \pm 0.5^{\circ}$	$109.6 \pm 0.7^{\circ}$	$79.1 \pm 0.4^{\circ}$	$65.1 \pm 0.5^{\circ}$	
Si-(OH) <sub>2</sub>	$116.8 \pm 0.4^{\circ}$	111 ± 0.6°	$77.4 \pm 0.4^{\circ}$	$74.4 \pm 0.8^{\circ}$	
Si-(CH <sub>3</sub> )(CH=CH <sub>2</sub> )	$116.2 \pm 0.4^{\circ}$	$100.6 \pm 0.8^{\circ}$	$78.4 \pm 0.3^{\circ}$	$70.6 \pm 2.3^{\circ}$	
Si((CH <sub>3</sub> )((CH <sub>2</sub> ) <sub>3</sub> OC(O)CCH=CH <sub>2</sub> )	118.2 ± 1.0°	90.6 ± 1.0°	$76.8 \pm 0.3^{\circ}$	64.8 ± 1.0°	
Si-(CH <sub>3</sub> )( (CH <sub>2</sub> ) <sub>3</sub> OC(O)C(CH <sub>3</sub> )=CH <sub>2</sub> )	$117.1 \pm 0.6^{\circ}$	93.8 ± 1.5°	$78.1 \pm 0.4^{\circ}$	$63.0 \pm 1.2^{\circ}$	
Si-(CH <sub>3</sub> )((CH <sub>2</sub> ) <sub>22</sub> CH <sub>3</sub> )	$117.9 \pm 0.4^{\circ}$	96.9 ± 1.9°	$78.0 \pm 0.4^{\circ}$	$16.2 \pm 5.5^{\circ}$	
$Si-(C_6H_5)_2$	$116.2 \pm 0.4^{\circ}$	$110.5 \pm 0.5^{\circ}$	$76.0 \pm 0.8^{\circ}$	$73.2 \pm 0.4^{\circ}$	
Si-((CH <sub>2</sub> ) <sub>7</sub> CH <sub>3</sub> ) <sub>2</sub>	$117.9 \pm 0.5^{\circ}$	95.5 ± 0.4°	69.1 ± 1.2°	$23.1 \pm 1.2^{\circ}$	

Samples (10 mg/mL) were spin casted on oxygen-plasma cleaned Si wafers at 900 rpm for 30 seconds. Contact angle measurements were run in triplicate. Surface roughness < 5nm (AFM and Optical Profilometry).



# **F-POSS Structures Synthesized**





# Reversible Addition-Fragmentation chain Transfer (RAFT) polymerization



Initiation

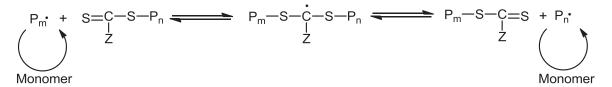
Initiator 
$$\xrightarrow{k_d}$$
 21.

$$P_n$$
 +  $S=C-S-R$   $P_n-S-\dot{C}-S-R$   $P_n-S-C=S+R$ 

Propogation

$$P_{n}^{\bullet}$$
 + Monomer  $\longrightarrow$   $P_{n}^{\bullet}$ 

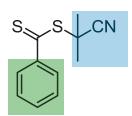
Termination



2 Radicals 

→ Dead polymer

#### **Chain Transfer Agent**



#### **RAFT Polymerization**

- Controlled polymerization
- Allows for block copolymers
- •Tune molecular weight

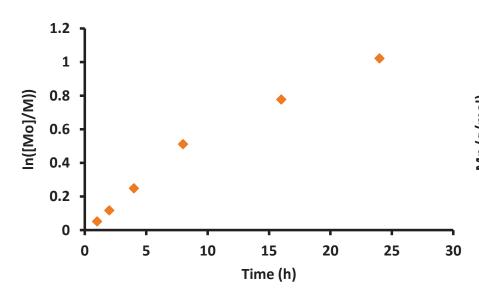


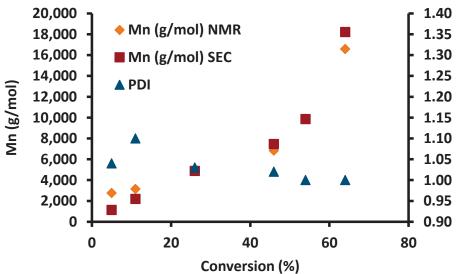
# RAFT polymerization of MMA in C<sub>6</sub>F<sub>6</sub>



$$\begin{array}{c|c}
S & CN \\
\hline
AIBN, 65^{\circ}C \\
\hline
C_6F_6
\end{array}$$
NC

- Testing RAFT in fluorinated solvent
- RAFT polymerization proceeds in C<sub>6</sub>F<sub>6</sub>
- Best control in first 10 hours



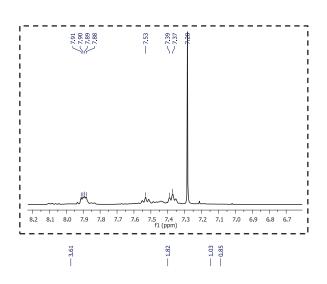


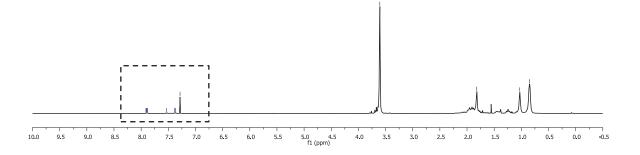


# RAFT copolymerization of P(F-POSS-MA)-co-PMMA









 $R_f = CH_2CH_2(CF_2)_7CF_3$ 



# RAFT copolymerization of P(F-POSS-MA)-co-PMMA



F-POSS	$M_w$		Conv.	water		hexadecane	
wt %	(g/mol)	PDI	%	$(\theta_{adv})$	$(\theta_{\rm rec})$	$(\theta_{adv})$	$(\theta_{ m rec})$
	F-POSS-	MMA		117.1 ± 0.6°	93.8 ± 1.5°	78.1 ± 0.4°	63.0 ± 1.2°
0	58,100	1.05	73	77.8 ± 1.3°	57.8 ± 2.5°	wetted	wetted
1	58,700	1.08	72	109.2 ± 2.4°	61.5 ± 1.9°	67.8° ± 1.4	wetted
5	23,000	1.01	30	117.8 ±1.6°	95.7 ± 5.9°	76.7 ± 1.1°	68.8 ± 1.9°
10	26,600	1.01	29	118.2 ± 1.4°	101.1 ±2.5°	77.2 ± 0.4°	69.5 ± 2.1°
25	37,700	1.03	41	120.8 ± 97.0°	97.0 ± 2.4°	82.9 ± 0.4°	74.6 ± 2.0°

SEC-MALLS conditions: 25°C, flow rate (1 mL/min), solvent (Asahiklin-225 [mixture of dichloropentafluoropropanes]), concentration measured with RI detector. Contact angle conditions: polymer solutions (20 mg/mL) were spun cast on SiO<sub>2</sub> wafers at 900 rpm.



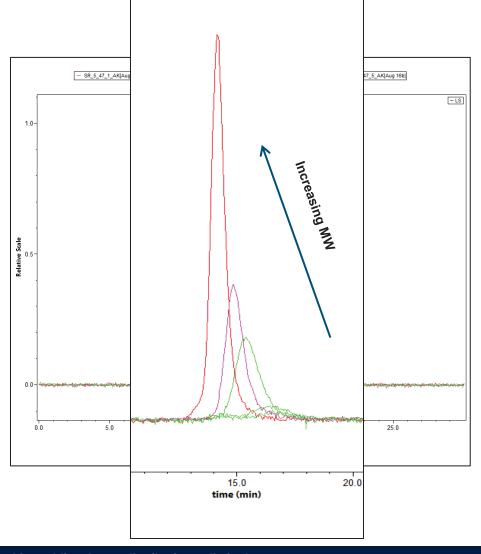
# RAFT copolymerization of P(F-POSS-MA)-co-PMMA



10% F-POSS	M <sub>n</sub>		Conv.
Time (hr)	(g/mol)	PDI	%.
1	4100	2.2	8
2	4,700	1.2	16
4	11,300	1.04	28
8	26,600	1.03	51

#### Determining impact of F-POSS on polymerization conditions

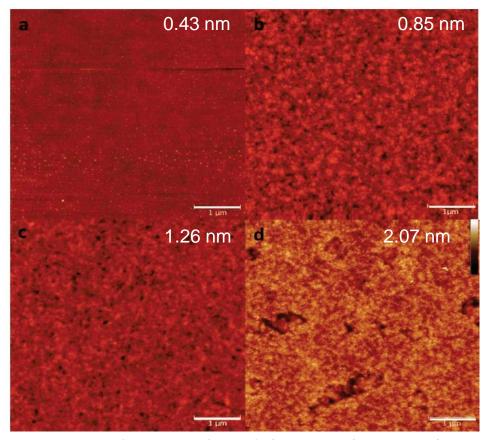
- No homopolymerization possible
- Polymerization difficult above 50 wt % F-POSS-MMA loading





# AFM of P(F-POSS-MA)-co-PMMA





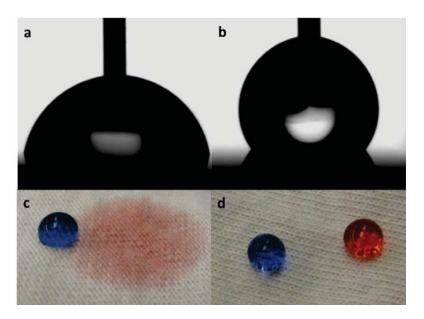
AFM image of spun cast films of a) 1 wt. % b) 5 wt. %. c) 10 wt. % and d) 25 wt.% F-POSS copolymer on SiO<sub>2</sub> from a 10 mg/mL concentrated solution in Asahiklin-225 at 900 rpm. Each image is shown with a z-scale of 0–10 nm. Top corner of each image root mean squared (rms) surface roughness.



# **PMMA Copolymerization Summary**



- Copolymerizations produced F-POSS based copolymers.
- Polymerization have trouble at higher F-POSS monomer feed ratios and are more controlled at lower conversion with RAFT initiator.
- Can we make homopolymer?

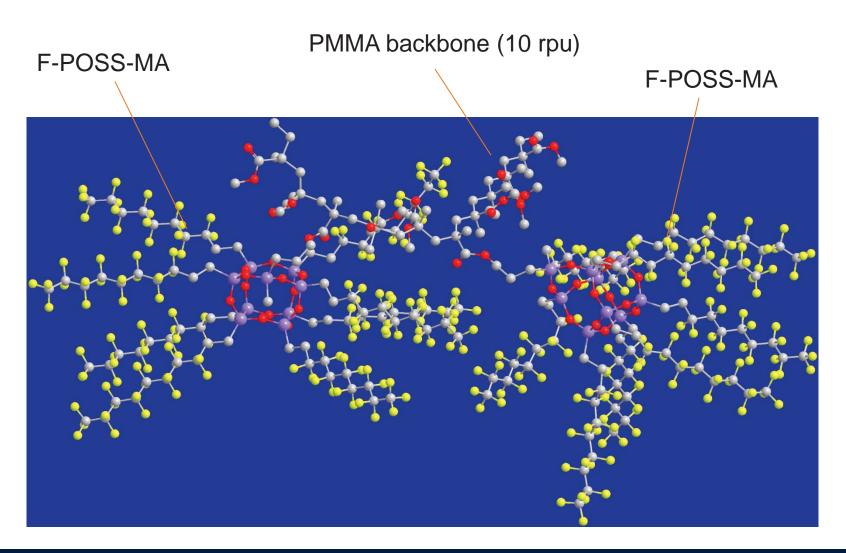


Static contact angle of a water droplet on a) 0 wt.% F-POSS copolymer or b) 25 wt.% F-POSS copolymer. Water (blue) and hexadecane (red) droplets on cotton fabric coated with c) 0 wt.% F-POSS copolymer and d) 25 wt. % F-POSS copolymer from 1% solution in Asahiklin-225.



### Is it crowded in here?







# **Extend the Chain**





# **Long Chain Monomer Synthesis**



$$+ (CH_3)SiHCl_2 \xrightarrow{\text{Karsted cat.}} 0 \\ \hline \\ \text{Toluene} \\ \hline$$



# **Free Radical Polymerization**



No Polymer 
$$C_6F_6$$
  $C_6F_6$   $C_6F_6$ 

- No polymerization



# **F-POSS Structures Synthesized**





# **Norbornene Synthesis**



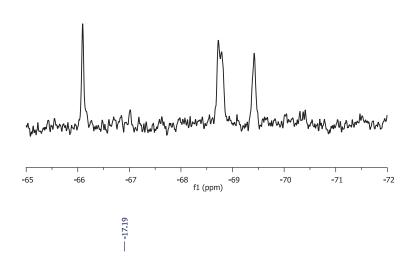
$$\begin{array}{c} R_f & \text{OH HO} & R_f \\ Si & Si & Si \\ R_f & Si & O \\ \end{array} \begin{array}{c} Si & Si \\ R_f & Si & O \\ \end{array} \begin{array}{c} Et_3N \\ C_6F_6 \end{array} \\ \\ R_f & Si & O \\ \end{array} \begin{array}{c} Si & Si \\ Si & O \\ \end{array} \begin{array}{c} Si & Si \\ Si & O \\ \end{array} \begin{array}{c} R_f & Si & O \\ Si & O \\ \end{array} \begin{array}{c} R_f & Si & O \\ \end{array} \begin{array}{c} Si & O \\ Si & O \\ \end{array} \begin{array}{c} R_f & Si & O \\$$

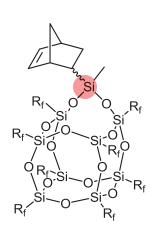
- Edge capping reactions typically have 52% yield
- Main side product is starting material (recycled)
- Disilanol can revert back to closed cage during reaction
- Norbornene functionalized F-POSS for ring opening metathesis polymerization (ROMP)

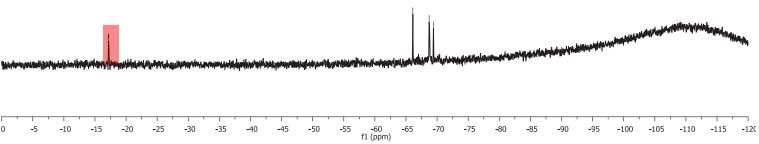


# <sup>29</sup>Si NMR









NMR: CDCl<sub>3</sub>/C<sub>6</sub>F<sub>6</sub>



# **ROMP** (Norbornene)



$$[Ru] = CI Ph$$

$$P(Cy)_3$$

Grubb's 2<sup>nd</sup> generation catalyst (soluble in hexafluorobenzene)

#### Polymerization

- Multiple polymerization in hexafluorobenzene
- 100:1, 50:1, 25:1 [monomer:catalyst]
- Reaction of 30 minutes (monitored by NMR)
- Higher monomer:catalyst ratios yield insoluble polymers
- Low  $T_g$  polymers (~5°C at 10°C/min ramp rate) [polynorbornene ~ 35-60°C]
- Need a method to determine molecular weight



# **ROMP** (Copolymerization)



### Two Approaches

$$+ \frac{[Ru]}{C_6F_6/CHCl_3} + \frac{[Ru]}{C_6F_6/CH$$

Random copolymer –problems occur with solubility of polynorbornene in C<sub>6</sub>F<sub>6</sub>/CHCl<sub>3</sub> mixture.

Block copolymers – keeping everything soluble remains a challenge here as well.



# **ROMP** (Cyclooctene)



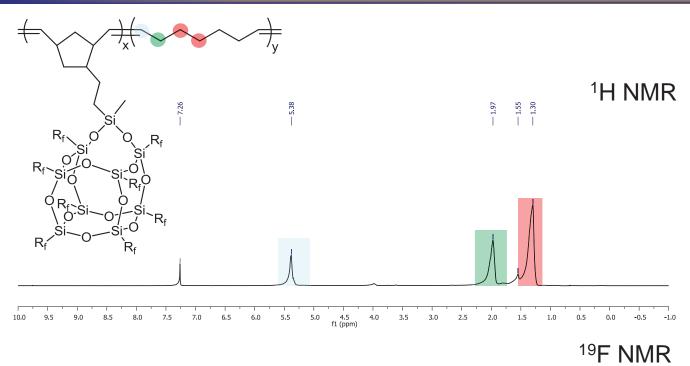
Random copolymer – resulting polymers are soluble cyclooctene solvents (chloroform, THF,

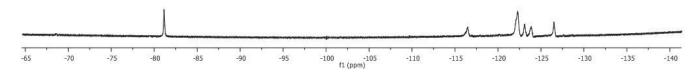
Block copolymers – resulting polymer is insoluble, possibly due to high molecular weight conversion F-POSS content 12 wt %.



# **NMR** of Copolymer







Polymer was precipitated in methanol, dissolved, and precipitated into asahiklin-225 before NMR.

 $R_{f} = CH_{2}CH_{2}CF_{2}CF_{2}CF_{2}CF_{2}CF_{2}CF_{2}CF_{3}$ 

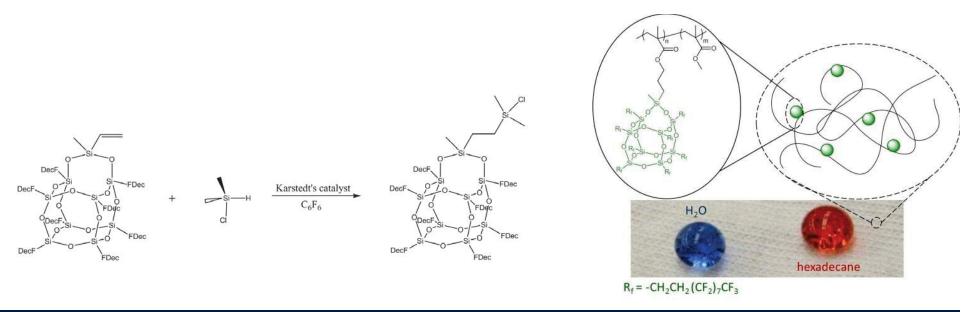




## **Summary**



- RAFT copolymerizations were shown to be controlled and highly reproducible.
- ROMP polymerization works well. Work needs to be done with catalyst choice, solvent, and other reaction condition.
- F-POSS compounds have a near limitless potential in producing a variety of new hydrophobic, oleophobic, or ominiphobic polymer composites.
  - Reaction mechanisms, polymer composites, block copolymers, etc....





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Ms. Vandana Vij Dr. Timothy Haddad

Dr. Greg Yandek Dr. Andrew Guenthner

Dr. Josiah Reams Ms. Dana Pinson

Ms. Yvonne Diaz $^{\xi}$  Dr. Christopher Sahagun

Cpt. Rebecca Stone\*

United States Air Force Academy:

Dr. Scott Iacono
Olawale Lawal<sup>§</sup>
Michael Duff<sup>§</sup>

**UT Dallas:** 

Dr. Dennis Smith

Mr. Raymond Compos\*

<sup>5</sup>Summer coop/student (undergraduate)

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<sup>\*</sup>Former group member



# **F-POSS Structures Synthesized**

